

Oral presentation | 7 Beam Technology and Nanofabrication | 7.1 X-ray technologies

## [13p-C31-1~11]7.1 X-ray technologies

Takeshi Higashiguchi(Utsunomiya Univ.), Atsushi Sunahara(Inst. for Laser Tech.)

Tue. Sep 13, 2016 1:45 PM - 5:00 PM C31 (Nikko Kujaku AB)

△ : Presentation by Applicant for JSAP Young Scientists Presentation Award

▲ : English Presentation

▼ : Both of Above

No Mark : None of Above

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3:30 PM - 4:00 PM

## ▲[13p-C31-7][2016 Fellow International Special Lectures] Optics and Coherence at X-ray and EUV Wavelengths

○David Attwood<sup>1</sup> (1.University of California,Berkeley)

Keywords:2016 Fellow International Special Lectures